



Patent
Attorney's Docket No. 015290-465

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Robert J. O'DONNELL et al.

Application No.: 09/749,921

Filed: December 29, 2000

For: CORROSION RESISTANT
COMPONENT OF SEMICONDUCTOR
PROCESSING EQUIPMENT AND
METHOD OF MANUFACTURE
THEREOF

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)
) Group Art Unit: 2812
)
) Examiner: Not Yet Assigned
)
) Confirmation No.: 6804
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INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Enclosed is an Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- [X] No additional fee for submission of an IDS is required.
- [] The fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- [] A certification under 37 C.F.R. § 1.97(e) is also enclosed.
- [] A certification under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- [] Charge \$_____ to Deposit Account No. 02-4800 for the fee due.
- [] A check in the amount of \$_____ is enclosed for the fee due.

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

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By: Peter K. Skiff
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Date: September 16, 2002

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit copies of the Notification of Transmittal of the International Search Report or the Declaration dated August 21, 2002 and Written Opinion dated August 23, 2002 for a corresponding application. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents not previously cited in an Information Disclosure Statement is enclosed.

U.S. Publication No. US2001/0003271A1 to Otsuki, published June 14, 2001;

European Patent No. 0443778A1, published June 26, 1991;

European Patent Application No. 0845545A1, published June 3, 1998;

Japanese Abstracts of Japan Publication No. 11345780, published December 14, 1999;

Deronzier, J.C. et al., "Plate Heat Exchangers in Liquid-Crystal Polymers",
Applied Thermal Engineering, Vol. 17, Nos. 8-10, pages 799-808, 1997;

Written Opinion dated August 23, 2002 for PCT/US01/43152;

Notification of Transmittal of the International Search Report or
the Declaration dated August 21, 2002 for PCT/US01/43152.

I, the undersigned, hereby certify that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

To assist the Examiner, the document is listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: _____


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